



Response Under 37 C.F.R. § 1.116  
Expedited Procedure  
Examining Group 2826  
PATENT  
ATTORNEY DOCKET NO.: 046124-5064

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:	)	
	)	
Hirofumi MIYAJIMA et al.	)	Confirmation No.: 3311
	)	
Application No.: 09/773,510	)	Group Art Unit: 2826
	)	
Filed: February 2, 2001	)	Examiner: J. Mondt
	)	
For: HEAT SINK AND SEMICONDUCTOR	)	<b>MS AF</b>
LASER APPARATUS AND	)	
SEMICONDUCTOR LASER STACK	)	
APPARATUS USING THE SAME	)	

Commissioner for Patents  
U.S. Patent and Trademark Office  
2011 South Clark Place  
**Customer Window, MS AF**  
Crystal Plaza Two, Lobby, Room 1B03  
Arlington, VA 22202

Sir:

**AMENDMENT**

In response to the Final Office Action dated May 16, 2003 (Paper No. 8), the period for response to which has been extended through November 17, 2003 (November 16, 2003 being a Sunday) by the attached petition for a three-month extension of time and appropriate fee, please amend the above-identified application as follows:

RECEIVED  
NOV 18 2003  
U.S. PATENT AND TRADEMARK OFFICE